

Notice of Allowability

Application No.

10/038,016

Examiner

Minh D A

Applicant(s)

IVES, R. LAWRENCE

Art Unit

2821

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. ☒ This communication is responsive to 8/04/04.
2. ☒ The allowed claim(s) is/are 11,16 and 20-46.
3. ☒ The drawings filed on 03 January 2002 are accepted by the Examiner.
4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
 - a) ☐ All b) ☐ Some* c) ☐ None of the:
 1. ☐ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

* Certified copies not received: _____.

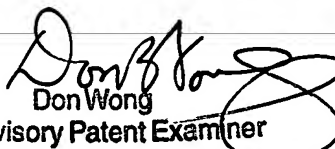
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.

THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.

5. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
 6. ☐ CORRECTED DRAWINGS (as "replacement sheets") must be submitted.
 - (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached
 - 1) ☐ hereto or 2) ☐ to Paper No./Mail Date _____.
 - (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date _____.
- Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
7. ☐ DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

Attachment(s)

1. ☒ Notice of References Cited (PTO-892)
2. ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08),
Paper No./Mail Date _____
4. ☐ Examiner's Comment Regarding Requirement for Deposit
of Biological Material
5. ☐ Notice of Informal Patent Application (PTO-152)
6. ☐ Interview Summary (PTO-413),
Paper No./Mail Date _____.
7. ☐ Examiner's Amendment/Comment
8. ☒ Examiner's Statement of Reasons for Allowance
9. ☐ Other _____.


Don Wong
Supervisory Patent Examiner
Technology Center 2800

Allowable Subject Matter

1. Claims 11, 16, 20-46 are allowed.
2. The following is an examiner's statement of reasons for allowance:

The prior art does not teach that, said body includes a magnetic field oriented axially to said sheet electron beam, and the strength of said magnetic field is substantially the same in said body as in said collector in combination with all limitations recited in independent claim 1.

The prior art does not teach, a conductive and substantially planar reflector electrically and mechanically attached to said interior cavity in said enclosure opposite said rectangular aperture, positioned at an angle to said incident rectangular sheet electron beam to reflect the electrons into the interior cavity in combination with all limitations recited in independent claim 16.

The prior art does not that that, said impinging surface angled with respect to said axis, thereby directing said backscattered primary electrons away from said electron beam; a dissipation cavity for receiving said backscattered primary electrons and said secondary electrons; where said primary electrons and said primary electrons have substantially linear backscattered trajectories in combination with all limitations recited in independent claim 30.

The prior art does no teach that, an impinging surface which is circularly symmetric about said axis, said impinging surface for interacting with said electron beam, said interaction generating backscattered primary electrons from said electron beam and optionally secondary electrons from said impinging surface; a dissipation

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cavity for receiving said backscattered primary electrons and said secondary electrons in combination with all limitations recited in independent claim 40.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

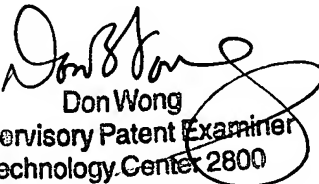
Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Symons . (US 5,650,751), Rawls, Jr. (US 3,824,425 and Doyle (US 3,717,787) are cited to show the depressed electron beam collector.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Examiner Minh A whose telephone number is (571) 272-1817. The examiner can normally be reached on M-F (5:30 –2:30 PM).

If attempts to reach the examiner by telephone is unsuccessful, the examiner's supervisor, Don Wong, can be reached on (571) 272-1834. The fax phone numbers for the organization where this application or proceeding is assigned are 703-872-9306 for regular communications and (703) 872-9319 for final communications.

Any inquiry of a general nature or relating to the status of this application should be directed to the Technology Center receptionist whose telephone number is (571) 272-1553.


Don Wong
Supervisory Patent Examiner
Technology Center 2800

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Dan Wong
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Examiner

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8/20/04